OIPE Appl. No. 10/609,311

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Spplication Serial No	10/609,311
Filing Date	June 26, 2003
	Micron Technology, Inc.
Group Art Unit	1756
Attorney's Docket No	Ml22-2236
_	021567
Title:	Semiconductor Processing Patterning Methods

RESPONSE TO JANUARY 23, 2006 FINAL OFFICE ACTION TO ACCOMPANY REQUEST FOR CONTINUED EXAMINATION

To:

Mail Stop RCE

Commissioner for Patents

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AMENDMENTS